

# Adam T Neal

## List of Publications by Citations

**Source:** <https://exaly.com/author-pdf/5520393/adam-t-neal-publications-by-citations.pdf>

**Version:** 2024-04-19

This document has been generated based on the publications and citations recorded by exaly.com. For the latest version of this publication list, visit the link given above.

The third column is the impact factor (IF) of the journal, and the fourth column is the number of citations of the article.

36  
papers

7,068  
citations

22  
h-index

37  
g-index

37  
ext. papers

7,996  
ext. citations

5.1  
avg, IF

5.96  
L-index

#	Paper	IF	Citations
36	Phosphorene: an unexplored 2D semiconductor with a high hole mobility. <i>ACS Nano</i> , <b>2014</b> , 8, 4033-41	16.7	4487
35	Channel length scaling of MoS <sub>2</sub> MOSFETs. <i>ACS Nano</i> , <b>2012</b> , 6, 8563-9	16.7	594
34	Switching mechanism in single-layer molybdenum disulfide transistors: an insight into current flow across Schottky barriers. <i>ACS Nano</i> , <b>2014</b> , 8, 1031-8	16.7	202
33	Molecular Doping of Multilayer $\text{MoS}_2$ Field-Effect Transistors: Reduction in Sheet and Contact Resistances. <i>IEEE Electron Device Letters</i> , <b>2013</b> , 34, 1328-1330	4.4	196
32	Demonstration of high mobility and quantum transport in modulation-doped $\text{Al}_x\text{Ga}_{1-x}\text{O}_3/\text{Ga}_2\text{O}_3$ heterostructures. <i>Applied Physics Letters</i> , <b>2018</b> , 112, 173502	3.4	192
31	Statistical study of deep submicron dual-gated field-effect transistors on monolayer chemical vapor deposition molybdenum disulfide films. <i>Nano Letters</i> , <b>2013</b> , 13, 2640-6	11.5	168
30	Donors and deep acceptors in $\text{AlGa}_2\text{O}_3$ . <i>Applied Physics Letters</i> , <b>2018</b> , 113, 062101	3.4	148
29	The Effect of Dielectric Capping on Few-Layer Phosphorene Transistors: Tuning the Schottky Barrier Heights. <i>IEEE Electron Device Letters</i> , <b>2014</b> , 35, 795-797	4.4	142
28	Ge-Doped $\beta\text{-Ga}_2\text{O}_3$ MOSFETs. <i>IEEE Electron Device Letters</i> , <b>2017</b> , 38, 775-778	4.4	124
27	Heteroepitaxy of N-type $\text{AlGa}_2\text{O}_3$ thin films on sapphire substrate by low pressure chemical vapor deposition. <i>Applied Physics Letters</i> , <b>2016</b> , 109, 132103	3.4	96
26	Intrinsic doping and gate hysteresis in graphene field effect devices fabricated on SiO <sub>2</sub> substrates. <i>Journal of Physics Condensed Matter</i> , <b>2010</b> , 22, 334214	1.8	91
25	Magneto-transport in MoS <sub>2</sub> : phase coherence, spin-orbit scattering, and the hall factor. <i>ACS Nano</i> , <b>2013</b> , 7, 7077-82	16.7	78
24	Effects of (NH <sub>4</sub> ) <sub>2</sub> S passivation on the off-state performance of 3-dimensional InGaAs metal-oxide-semiconductor field-effect transistors. <i>Applied Physics Letters</i> , <b>2011</b> , 99, 152113	3.4	63
23	Incomplete Ionization of a 110 meV Unintentional Donor in $\text{AlGaO}$ and its Effect on Power Devices. <i>Scientific Reports</i> , <b>2017</b> , 7, 13218	4.9	60
22	Towards High-Mobility Heteroepitaxial $\text{AlGa}_2\text{O}_3$ on Sapphire (Dependence on The Substrate Off-Axis Angle. <i>Physica Status Solidi (A) Applications and Materials Science</i> , <b>2018</b> , 215, 1700467	1.6	51
21	P-type conduction in two-dimensional MoS <sub>2</sub> via oxygen incorporation. <i>Applied Physics Letters</i> , <b>2017</b> , 110, 193103	3.4	46
20	Size-Dependent-Transport Study of $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}$ Gate-All-Around Nanowire MOSFETs: Impact of Quantum Confinement and Volume Inversion. <i>IEEE Electron Device Letters</i> , <b>2012</b> , 33, 967-969	4.4	44

19	Two-dimensional TaSe <sub>2</sub> metallic crystals: spin-orbit scattering length and breakdown current density. <i>ACS Nano</i> , <b>2014</b> , 8, 9137-42	16.7	40
18	Lateral $\alpha$ -Ga <sub>2</sub> O <sub>3</sub> field effect transistors. <i>Semiconductor Science and Technology</i> , <b>2020</b> , 35, 013002	1.8	38
17	MOCVD growth of high purity Ga <sub>2</sub> O <sub>3</sub> epitaxial films using trimethylgallium precursor. <i>Applied Physics Letters</i> , <b>2020</b> , 117, 262101	3.4	34
16	Metal contacts to MoS <sub>2</sub> : A two-dimensional semiconductor <b>2012</b> ,		33
15	$\alpha$ -Gallium oxide power electronics. <i>APL Materials</i> , <b>2022</b> , 10, 029201	5.7	33
14	Pulsed Power Performance of $\alpha$ -Ga <sub>2</sub> O <sub>3</sub> MOSFETs at L-Band. <i>IEEE Electron Device Letters</i> , <b>2020</b> , 41, 989-992	4.4	19
13	(Invited) Fundamentals in MoS <sub>2</sub> Transistors: Dielectric, Scaling and Metal Contacts. <i>ECS Transactions</i> , <b>2013</b> , 58, 203-208	1	17
12	Reduction of unintentional Si doping in $\alpha$ -Ga <sub>2</sub> O <sub>3</sub> grown via plasma-assisted molecular beam epitaxy. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , <b>2020</b> , 38, 043403	2.9	15
11	Weak localization in few-layer black phosphorus. <i>2D Materials</i> , <b>2016</b> , 3, 024003	5.9	15
10	$\alpha$ -Ga <sub>2</sub> O <sub>3</sub> defect study by steady-state capacitance spectroscopy. <i>Japanese Journal of Applied Physics</i> , <b>2018</b> , 57, 091101	1.4	12
9	Transport studies in 2D transition metal dichalcogenides and black phosphorus. <i>Journal of Physics Condensed Matter</i> , <b>2016</b> , 28, 263002	1.8	10
8	Si doping in MOCVD grown (010) $\alpha$ -(Al <sub>x</sub> Ga <sub>1-x</sub> ) <sub>2</sub> O <sub>3</sub> thin films. <i>Journal of Applied Physics</i> , <b>2022</b> , 131, 145301	2.5	5
7	Ambipolar phosphorene field-effect transistors with dielectric capping <b>2014</b> ,		4
6	(Invited) Atomic-Layer-Deposited High-k Dielectric Integration on Epitaxial Graphene. <i>ECS Transactions</i> , <b>2010</b> , 33, 459-466	1	4
5	Study of defects in $\alpha$ -Ga <sub>2</sub> O <sub>3</sub> by isothermal capacitance transient spectroscopy. <i>Journal of Vacuum Science and Technology B: Nanotechnology and Microelectronics</i> , <b>2019</b> , 37, 041204	1.3	3
4	(Invited) ALD High-k as a Common Gate Stack Solution for Nanoelectronics. <i>ECS Transactions</i> , <b>2010</b> , 28, 51-68	1	3
3	Electronic Transport Properties in Top-Gated Epitaxial Graphene on Silicon Carbide with ALD Al <sub>2</sub> O <sub>3</sub> High-K Dielectric <b>2010</b> ,		1
2	Zeeman spin-splitting in the (010) $\alpha$ -Ga <sub>2</sub> O <sub>3</sub> two-dimensional electron gas. <i>Applied Physics Letters</i> , <b>2019</b> , 115, 262103	3.4	0

1 Electrical Properties 1. *Springer Series in Materials Science*, **2020**, 389-405

0.9